

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 294550US41PCT		SERIAL NO. 10/588,703	
LIST OF REFERENCES CITED BY APPLICANT		APPLICANT					
		Jean DIJON, et al.					
		FILING DATE		GROUP			
		August 8, 2006		1715			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
AA							
AB							
AC							
AD							
AE							
AE							
AG							
AH							
AI							
AJ							
AK							
AL							
AM							
AN							
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION		
					YES	NO	
AO							
AP							
AQ							
AR							
AS							
AT							
AU							
AV							
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
	AW	Office Action issued May 10, 2011, in Japan Patent Application No. 2006-551895, filed April 28, 2011, (with English-language Translation).					
	AX	C.M. Cotell, et al., "Microstructural Development of Thin Films Grown by Pulsed Laser Deposition," <i>Materials Science and Engineering</i> B32 (1995) 221-230.					
	AY	Masako Yudasaka et al., "Specific Conditions for Ni Catalyzed Carbon Nanotube Growth by Chemical Vapor Deposition," <i>Appl. Phys. Lett.</i> 67 (17) October 23, 1995.					
	AZ				<input type="checkbox"/> Additional References sheet(s) attached		
Examiner					Date Considered		
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							